





The Devil's in the Details: Photometric Biases in Modern Surveys

Stephen Portillo^{1,2,*} and **Josh Speagle^{1,*}** and Doug Finkbeiner¹ ¹Harvard U., ²DIRAC (U. of Washington) *Equal contribution

Portillo, Speagle, & Finkbeiner (**PSF**) subm., arxiv:1902.02374

What is Photometry?





Keck Telecope (Hawaii)





Spectral Energy **Distribution (SED)**

8000

9000



Images to Catalogs



Point Spread

 Most of my work focuses on using photometry from large surveys.

"Big Data"-oriented work

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- Understanding the data is important.

"Big Data"-oriented work

- Most of my work focuses on using photometry from large surveys.
- Understanding the data is important.
- Small effects can add up over large populations.

- The Finkbeiner group built up PCAT (Probabilistic Cataloging):
 - sampling from the transdimensional space of all possible catalogs





Daylan, Portillo, & Finkbeiner (2016)

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How well can you model a single source?



Daylan, Portillo, & Finkbeiner (2016)

- Estimated fluxes are biased.
- Uncertainties are underestimated.

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First reaction:

- No surprise: photometry is hard.
- Model mismatch (PSF, source)
- Blending issues
- Background estimation
- Unresolved sources
- Detection limits/selection effects
- Etc.



unWISE: Schlafly et al. (2019)

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This is true even with perfect models and data!





unWISE: Schlafly et al. (2019)

• Single, isolated **point source** in **one band** with PSF known and Gaussian background noise.

 $n \times m$ footprint



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Likelihood

 $\ln \mathcal{L}(x, y, f, b)$

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Likelihood

 $\ln \mathcal{L}(x, y, f, b)$

Maximum-Likelihood Solution

$$\partial_f \ln \mathcal{L}(x, y, f, b) = 0$$

• Normal log-likelihood:

$$\ln \mathcal{L}(x, y, f, b) = -\frac{nm}{2} \ln(2\pi\sigma^2) - \frac{1}{2\sigma^2} \sum_{i} (\hat{f}_i - fp_i(x, y) - b)^2$$

Normalization Residual

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Normalization Residual

• Flux and error:

$$f_{\mathrm{ML}}(x, y, b) = \frac{\sum_{i} (\hat{f}_i - b) p_i(x, y)}{\sum_{i} p_i^2(x, y)}$$

"Naïve" error

$$\tilde{\sigma}_f^2(x,y) \equiv -\left(\partial_f^2 \ln \mathcal{L}\right)^{-1} = \frac{\sigma^2}{\sum_i p_i^2(x,y)} \equiv \boxed{A_{\text{psf}}(x,y) \times \sigma^2}$$

$$4\pi s^2 \text{ for Gaussian}$$

• Normal log-likelihood:

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Normalization
Residual
• Position error:
$$\stackrel{\text{PSF "Smoothness"}}{\tilde{\sigma}_x^2(x_{\text{ML}}, y, f, b)} = \frac{\sigma^2}{f^2} \left(\sum_{i} (\partial_x p_i(x_{\text{ML}}, y))^2 - \frac{1}{f} \left((\hat{f}_i - b) - fp_i(x_{\text{ML}}, y) \right) \partial_x^2 p_i(x_{\text{ML}}, y) \right)^{-1}$$
SNR
$$\stackrel{\text{PSF "Variability"}}{\text{PSF "Variability"}}$$

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Normalization Residual

• Position error:

"Naïve" error

$$\tilde{\sigma}_x^2(x_{\mathrm{ML}}, y, f, b) \approx \frac{1}{f^2} \frac{\sigma^2}{\sum_i \left(\partial_x p_i(x_{\mathrm{ML}}, y)\right)^2} \equiv \left[S_{\mathrm{psf}}(x_{\mathrm{ML}}, y) \times \left(\frac{f^2}{\sigma^2}\right)^{-1}\right]$$

$$8\pi s^4 = 2s^2 A_{\rm psf}$$
 for Gaussian

• Normal log-likelihood:

$$\ln \mathcal{L}(x, y, f, b) = -\frac{nm}{2} \ln(2\pi\sigma^2) - \frac{1}{2\sigma^2} \sum_{i} (\hat{f}_i - fp_i(x, y) - b)^2$$

Normalization Residual

• **Background** and error:

$$b_{\mathrm{ML}}(x, y, f) = \frac{1}{nm} \sum_{i} \hat{f}_i - f p_i(x, y)$$

$$\tilde{\sigma}_b^2 = \frac{\sigma^2}{nm} \equiv \frac{\sigma^2}{A}$$

"Naïve" error

Biases in PSF Photometry

Assume background known



Random noise sometimes leads to high fluctuations.



Random noise sometimes leads to high fluctuations.



It also leads to low fluctuations with equal probability.



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It also leads to low fluctuations with equal probability.





Because fluctuations are symmetric, the maximum-likelihood estimate is unbiased.

n × m footprint

Flux Distribution Ideal σ_{f} f_{ML} Fainter \longrightarrow Brighter

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Position Unknown



The position is centered at the true position when random noise generates high fluctuations...

$n \times m$ footprint Fainter



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But when there are low fluctuations at the true position, a better fit can be achieved at a different position.

$n \times m$ footprint



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Position Unknown



Brighter

ML

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But when there are low fluctuations at the true position, a better fit can be achieved at a different position.





Because fluctuations are asymmetric, the maximum-likelihood estimate is biased.

Biases in PSF Photometry

- While the MLE is *consistent* (unbiased as N → infinity), not necessarily unbiased.
- Recast the problem with random variables:

$$\hat{\mathbf{f}} = f^* \mathbf{p}(x^*, y^*) + \mathbf{b}^* + \mathbf{C}^{1/2} \mathbf{Z}$$

$$f$$
Standard Normal Random Numbers

Biases in PSF Photometry: Ideal Case

• Assume we know position (x*, y*) and background b*.

$$\ln \mathcal{L}(x^*, y^*, f, b^*) = -\frac{nm}{2} \ln(2\pi\sigma^2) - \frac{1}{2\sigma^2} \sum_i ((f^* - f)p_i(x^*, y^*) + \sigma Z_i)^2$$
$$f_{\rm ML}(x^*, y^*, b^*) = f^* + \frac{\sum_i Z_i p_i(x^*, y^*) / \sigma}{\sum_i p_i^2(x^*, y^*) / \sigma^2}$$

1

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1

$$f_{\mathrm{ML}}(x^*,y^*,b^*) \sim \mathcal{N}(f^*,\sigma_f^2(x^*,y^*))$$

Biases in PSF Photometry: General Case

 In general, if we knew the truth and simulated the data, we'd end up with:

$$\operatorname{n} \mathcal{L}(x^*, y^*, f^*, \mathbf{b}^*) = -\frac{1}{2} \ln(\det(2\pi \mathbf{C})) - \frac{1}{2} \sum_i Z_i^2$$



Biases in PSF Photometry: General Case

• When you introduce parameters, they "absorb" some of the noise:

$$(\hat{\mathbf{f}} - \mathbf{f}_{\boldsymbol{\theta}_{\mathrm{ML}}})^{\mathrm{T}} \mathbf{C}^{-1} (\hat{\mathbf{f}} - \mathbf{f}_{\boldsymbol{\theta}_{\mathrm{ML}}}) \sim \chi^2_{nm-p}$$

• The variation in the parameters contains the missing noise:

$$(\boldsymbol{\theta}^* - \boldsymbol{\theta}_{\mathrm{ML}})^{\mathrm{T}} \mathbf{C}_{\boldsymbol{\theta}}^{-1} (\boldsymbol{\theta}^* - \boldsymbol{\theta}_{\mathrm{ML}}) \sim \chi_p^2$$
• We can exploit this to relate our two estimators in distribution:

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MLE residual with position fixed

 $(\hat{\mathbf{f}} - f_{\mathrm{ML}}^* \mathbf{p}_{x^*,y^*})^{\mathrm{T}} \mathbf{C}^{-1} (\hat{\mathbf{f}} - f_{\mathrm{ML}}^* \mathbf{p}_{x^*,y^*})$

• We can exploit this to relate our two estimators in distribution:

Equal in distribution **MLE residual with position free** $(\hat{\mathbf{f}} - f_{\mathrm{ML}}\mathbf{p}_{x_{\mathrm{ML}},y_{\mathrm{ML}}})^{\mathrm{T}}\mathbf{C}^{-1}(\hat{\mathbf{f}} - f_{\mathrm{ML}}\mathbf{p}_{x_{\mathrm{ML}},y_{\mathrm{ML}}}) + X_{2}^{2} \sim (\hat{\mathbf{f}} - f_{\mathrm{ML}}^{*}\mathbf{p}_{x^{*},y^{*}})^{\mathrm{T}}\mathbf{C}^{-1}(\hat{\mathbf{f}} - f_{\mathrm{ML}}^{*}\mathbf{p}_{x^{*},y^{*}})$ $\chi^{2}(\mathrm{dof} = 2)$ random variable

• We can use this to get a first-order bias correction:

$$\mathbb{E}[f_{\mathrm{ML}}^*] \approx f_{\mathrm{ML}} \left[1 - \frac{\tilde{\sigma}_{f_{\mathrm{ML}}}^2}{f_{\mathrm{ML}}^2} \right]$$

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• Applying this correction increases the variance:

$$\tilde{\sigma}_{f_{\rm ML}^*} = \sqrt{\tilde{\sigma}_{f_{\rm ML}}^2 + \mathbb{V}[f_{\rm ML}^*]} \approx \tilde{\sigma}_{f_{\rm ML}} \left(1 + \frac{1}{2} \frac{\mathbb{V}[f_{\rm ML}^*]}{\tilde{\sigma}_{f_{\rm ML}}^2} \right) = \tilde{\sigma}_{f_{\rm ML}} \left(1 + \frac{1}{2} \frac{\tilde{\sigma}_{f_{\rm ML}}^2}{f_{\rm ML}^2} \right)$$

• This is an example of the **bias-variance trade-off**.

• Flux: +1% bias.

Biases in PSF Photometry

Position unknown, background known



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 Need to account for covariance between background and other parameters.

$$\mathbf{C}_{\boldsymbol{\theta}}(\boldsymbol{\theta}_{\mathrm{ML}}) \approx -\mathbb{E}_{\mathbf{D}} \left[\partial_{\boldsymbol{\theta}}^{2} \ln \mathcal{L}(\boldsymbol{\theta}_{\mathrm{ML}}) | \boldsymbol{\theta}_{\mathrm{ML}} \right]^{-1} \\ \equiv \left(\mathcal{F}_{\boldsymbol{\theta}}(\boldsymbol{\theta}_{\mathrm{ML}}) \right)^{-1} = -\left(\partial_{\boldsymbol{\theta}}^{2} \ln \mathcal{L}(\boldsymbol{\theta}_{\mathrm{ML}}) \right)^{-1}$$

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Position unknown, background unknown



 Need to account for covariance between background and other parameters.

$$\partial_f \partial_b \ln \mathcal{L}(x, y) = -\frac{1}{\sigma^2} \sum_i p_i(x, y) = -\frac{1}{\sigma^2}$$
$$\partial_x \partial_b \ln \mathcal{L}(x, y) = -\frac{f}{\sigma^2} \sum_i \partial_x p_i(x, y) \approx 0$$

Oversampled limit: can approximate sum with integral

• Flux: +1% bias.

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$$\sigma_f^2(x,y) \!=\! \frac{A}{A - A_{\rm psf}(x,y)} \times \tilde{\sigma}_f^2$$

- Flux: +1% bias.
- Variance: -0.1% bias.

Biases in PSF Photometry

Position unknown, background unknown



Background variable

Biases in PSF Photometry

Position unknown, background unknown



Extra degrees of freedom allows fit to chase noise.

Error Bias

$$\frac{\delta_{\tilde{\sigma}_f^2}}{\sigma_f^2}(x,y) = -\frac{A_{\text{psf}}(x,y)}{A}$$



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 $p = 3 \rightarrow 6 - 10$ Shape parameters soak up noise.

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Ignoring covariances underestimates errors. Shape parameters add covariances.

• More parameters, more covariances, larger effective area

Flux Bias



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Flux Bias



Extra degrees of freedom allows fit to chase noise.

 $p = 3 \rightarrow 6 - 10$ Shape parameters soak up noise.

Error Bias
$$A_{gal+psf}$$

 $\frac{\delta_{\tilde{\sigma}_{f}^{2}}}{\sigma_{f}^{2}}(x,y) = -\frac{2A_{psf}(x,y)}{A}$

Ignoring covariances underestimates errors.

Shape parameters add covariances. Extended shape impedes background estimation.

• More parameters, more covariances, larger effective area



• More parameters, more covariances, larger effective area



Impacts

• Emerging tension in large-scale clustering between Cosmic Microwave Background (CMB) and weak lensing.



Impacts

- Offsets due to differences in inferred redshift (distance) distribution of galaxies from photometry.
 - Flux overestimated \rightarrow slightly closer \rightarrow smaller redshift \rightarrow population bias.



Biases in Multi-band Photometry

 $n \times m$ footprint











• Detect in one band, fix position, force photometry in others







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 $n \times m$ footprint









Biases in Joint Multi-band Photometry

• Fit all bands simultaneously (~ detect on stack, force in bands)







Biases in Joint Multi-band Photometry

Fit all bands simultaneously (~ detect on stack, force in bands)

D. MAXIMUM-LIKELIHOOD BIASES USING BIAS TENSORS

As discussed in §5, ML estimators have a bias δ which tends to zero as the signal-to-noise ratio (SNR) increases. Cox & Snell (1968) found that the leading-order bias term for any parameter s can be found with

$$\delta_s(\boldsymbol{\theta}_{\mathrm{ML}}) = \sum_{r,t,u} (\boldsymbol{\mathcal{F}}^{-1}(\boldsymbol{\theta}_{\mathrm{ML}}))_{rs} (\boldsymbol{\mathcal{F}}^{-1}(\boldsymbol{\theta}_{\mathrm{ML}}))_{tu} (\boldsymbol{\mathcal{B}}(\boldsymbol{\theta}_{\mathrm{ML}}))_{rtu}$$
(D34)

where

$$(\mathcal{B}(\boldsymbol{\theta}_{\mathrm{ML}}))_{rtu} \equiv \mathbb{E}_{\mathbf{D}} \left[\frac{1}{2} \partial_r \partial_t \partial_u \ln \mathcal{L}(\boldsymbol{\theta}_{\mathrm{ML}}) + (\partial_t \ln \mathcal{L}(\boldsymbol{\theta}_{\mathrm{ML}}))(\partial_r \partial_u \ln \mathcal{L}(\boldsymbol{\theta}_{\mathrm{ML}})) \left| \boldsymbol{\theta}_{\mathrm{ML}} \right]$$
(D35)

is the bias tensor and $\mathbb{E}_{\mathbf{D}}[\cdot|\boldsymbol{\theta}_{\mathrm{ML}}]$ is the expectation value with respect to the data \mathbf{D} for $\boldsymbol{\theta}_{\mathrm{ML}}$ fixed.

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D. MAXIMUM-LIKELIHOOD BIASES USING BIAS TENSORS
Biases in Joint Multi-band Photometry



Biases in Joint Multi-band Photometry



Biases in Multi-band Photometry

Forced Photometry

Positive bias in detection band. Negative bias in forced bands. **Doubly-biased colors.**

Joint Photometry

Positive bias evenly spread across all bands. Unbiased colors.

Proof?

Proof?

- Two test cases:
 - HSC SynPipe (mock data, real pipeline)
 - SDSS Stripe 82 (real data, real pipeline)

Prime Focus Instrument on Subaru (8.2 m)

• Fov (1.5° in diameter) 10xSuprime-Cam

- Primary science driver : weak lensing
- 2014 2019, 300 nights
- Deep multi-band imaging (grizy, i~26, y~24) over 1500 deg². About 940xCOSMOS!
- Excellent seeing (0.6"- 0.7")
- In hand : 100 deg² to full depth



Credit: Song Huang

- Fake object pipeline: inject fake objects into real images drawn from realistic SED distributions.
- "Forced" photometry: detect in iband, force in others
- PSF magnitudes



Credit: Song Huang

Good seeing: ~0.6"



Poor seeing: ~1.2"



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Results look like single-band fits!









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Results look like single-band fits!

Implementation-specific effect:

- HSC pipeline allows for "local re-centering" of forced position.
- Enough to undo forcing effect!









sdss.org

cfht.hawaii.org

- Repeated imaging: compare catalog computed from a "deep stack" of all images ("truth") vs individual runs ("realization")
- "Forced" photometry: detect in r-band, force in others
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- "Forced" photometry: detect in r-band, force in others
- PSF magnitudes
- HSC pipeline built off of SDSS pipeline.
 Same implementation and effect.
- SDSS/HSC will also serve as basis for LSST pipeline.



What about galaxies?

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- Much more complicated:
 - Models are known to have deficiencies matching real data.
 - Models involve much more parameters.
 - Many more algorithmic choices involved/taken when fitting.

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- Much more complicated:
 - Models are known to have deficiencies matching real data.
 - Models involve much more parameters.
 - Many more algorithmic choices involved/taken when fitting.
- Recommend directly calibrating from pipeline tests.

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- If we know that the MLE is biased and our models may be wrong, why not do something simple like aperture photometry?
 - 1. Apertures will "miss" flux in *all* cases, requiring "**aperture corrections**" that dominate the error budget and are hard to estimate.
 - 2. Apertures are still subject to centering bias.
 - 3. SNR is lower due to much more background noise.
 - 4. Estimate degrades (MLE improves) with larger area.
 - 5. Unable to jointly model multiple images.
 - 6. Less amenable to statistical analysis than MLE.


Cautionary note: Aperture photometry

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Has a purpose, but should be used judiciously!

burro.case.edu



Aperture vs PSF Photometry: SDSS Stripe 82



Wavelength

Summary

- MLE photometry has a bias that goes as SNR^-2.
- Proportional to number of parameters of fit: (p-1)/2
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- Mild effect for stars (1% @ SNR=10), more severe for galaxies (>2.5% @ SNR=10).
- Forced photometry is dangerous. Joint is better.

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- Proportional to number of parameters of fit: (p-1)/2
- Naïve errors underestimated due to ignored covariances.
- Mild effect for stars (1% @ SNR=10), more severe for galaxies (>2.5% @ SNR=10).
- Forced photometry is dangerous. Joint is better.
- Behavior is sensitive to implementation talk to pipeline teams!
- These biases likely present in many modern photometry catalogs.